

Notice of References Cited	Application/Control No. 10/663,767	Applicant(s)/Patent Under Reexamination HIRAYAMA ET AL.	
	Examiner Scott Egan	Art Unit 2621	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,407,415	06-2002	Lee, Chun Tak	257/215
*	C	US-6,765,277	07-2004	Chen et al.	257/459
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	L	US-			
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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